

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#2

Bradley F. Bowden

Kenneth E. Hrdina John F. Wight, Jr. Chunzhe C. Yu

Serial No:

10/086,231

Filed:

February 27, 2002

For:

HIGH PURITY GLASS BODIES FORMED

BY ZERO SHRINKAGE CASTING

ENT

Group Art Unit: 2811

Examiner: To Be Assigned

TC 1700

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.56, 1.97 – 1.98

Asst. Commissioner of Patents and Trademarks Washington, DC 20231

Dear Sir:

The Examiner's attention is hereby directed to the following reference(s) listed on the attached Form PTO-1449 for consideration in connection with the examination of the above-identified patent application. One copy of the reference(s) is enclosed.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the enclosed documents constitute "prior art." If it should be determined that any of the submitted documents do not constitute "prior art" under United States law, applicant(s) reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

Applicant(s) further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the enclosed references, should one or more of the references be applied against the claims of the present application.

Respectfully submitted,

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(---)--

Date:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Asst. Commissioner of Patents and Trademarks, Washington, D.C. 20231

on ______

Date of Deposi

Signature: Colleen E. Doherty

Revision: March 7, 2000

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FORM PTO-1449 (MODIFIED)

ATTORNEY DOCKET NO.

SERIAL NO.

LIST OF PATENTS AND PUBLICATIONS

SP01-331

10/086,231

FOR APPLICANTS INFORMATION DISCLOSURE STATEMENT

APPLICANT Bowden et al.

FILING DATE February 27, 2002

GROUP:

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

| Examiner Initial | | Document Number | Date | Name | Class | Sub- Class | Filing Date if Approp. |
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EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

| A 1 | OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.) |
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